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Serial No. 10/811,624

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Attorney Docket No.: 0013 P00903-US2

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	IN THE U.S. PATENT AND TRADEMARK OFFICE	
Applicant : Serial No. : Filed : Title :	CHIROVSKY et al. 10/811,624 March 29, 2004 Method of Self-Aligning an Oxide Aperture with ar Intra-Cavity Contact in a Long Wavelength VCSE	L
Examiner :	MULPURI, Savitri	Art Unit: 2812
Assistant Commit Washington DC 2	issioner for Patents 20231	
	RESPONSE TO OFFICE ACTION	
Sir/Ma'am:		
Responsiv	ve to the Office Action dated September 2, 2004, the	following
arguments are pr	resented for consideration:	
1		•
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